

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Fumitsugu FUKUYO et al.)	
Application No.: 10/537,509)	Confirmation No.: 4531
Filed: November 30, 2005)	Group Art Unit: 2892
For: METHOD FOR CUTTING)	Examiner: Elias Ullah
SEMICONDUCTOR SUBSTRATE)	

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Window, Mail Stop RCE
Alexandria, VA 22314

Sir:

AMENDMENT

In response to the final Office Action dated May 12, 2009, and pursuant to 37 C.F.R. § 1.116, the period for response to which extends through November 12, 2009 with the concurrently filed Petition for a Three-Month Extension of Time, please amend the above-identified application as follows. A Request for Continued Examination (RCE) is being filed concurrently herewith.